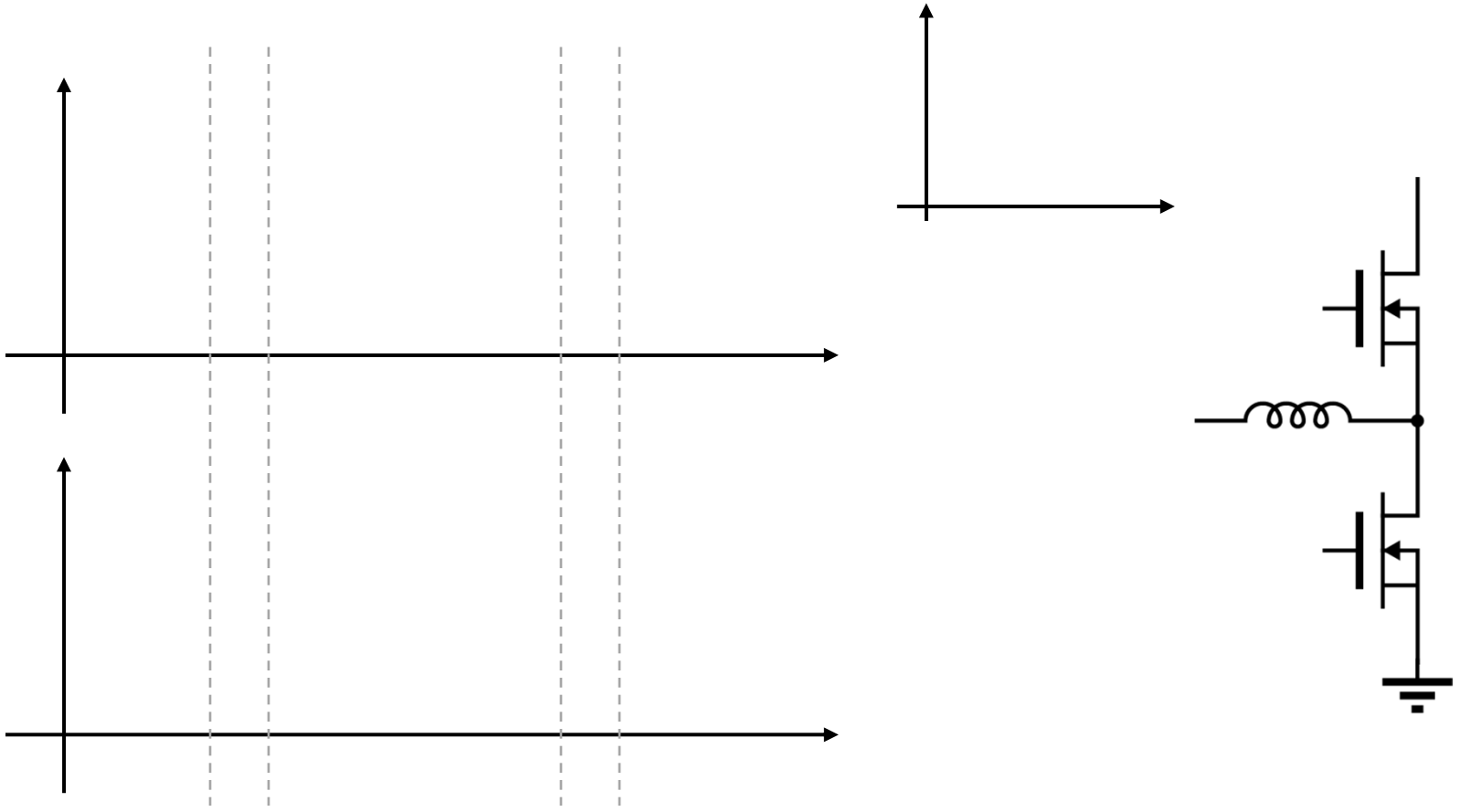
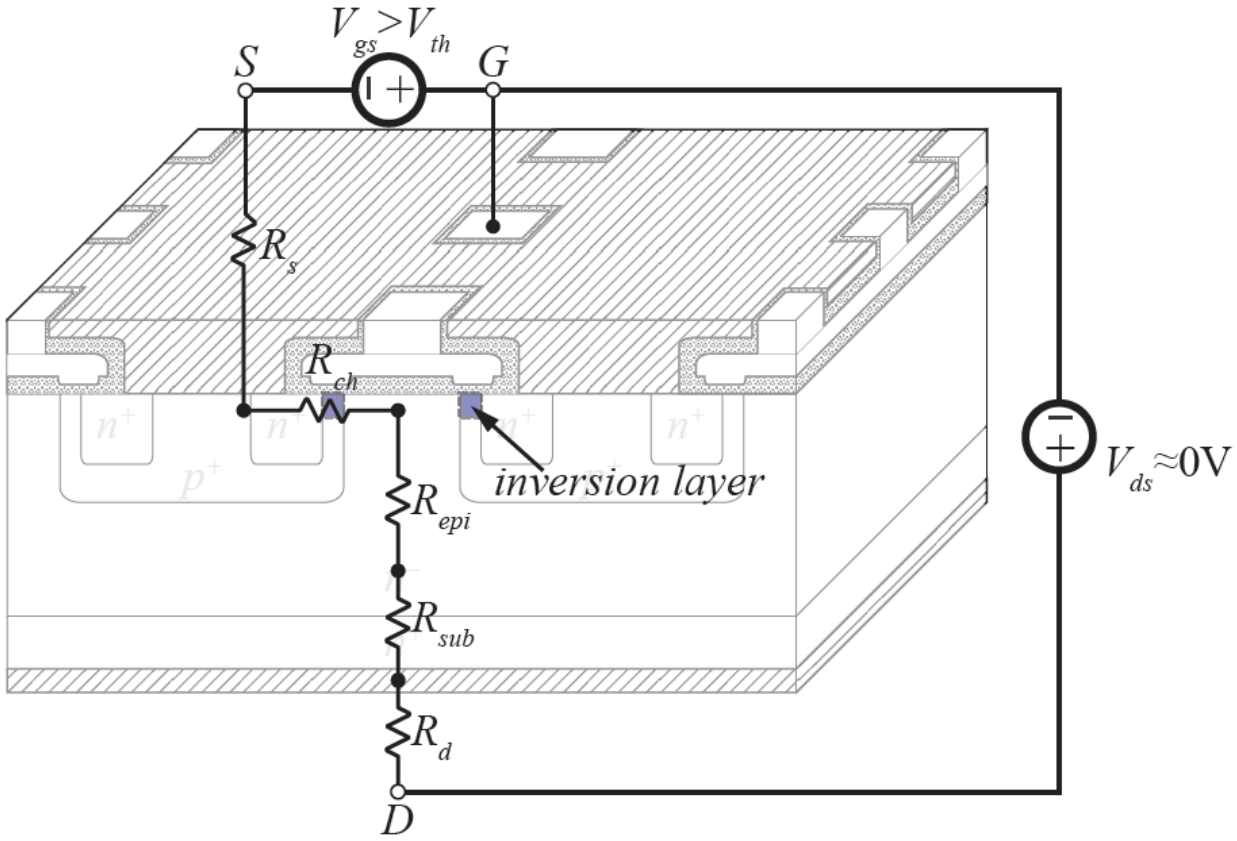
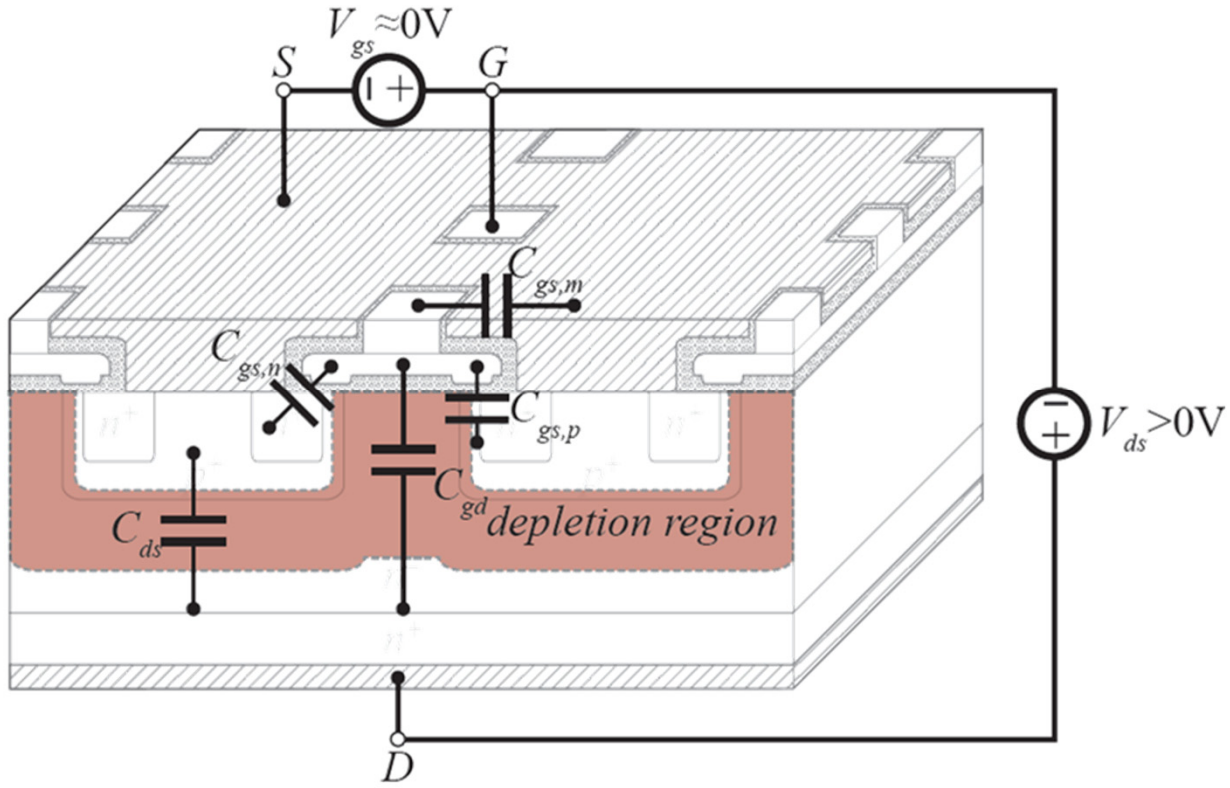
HARD SWITCHING ANALYSIS

Synchronous Switching



MOSFET Cross Section





Resistance Contributions Vs. Voltage

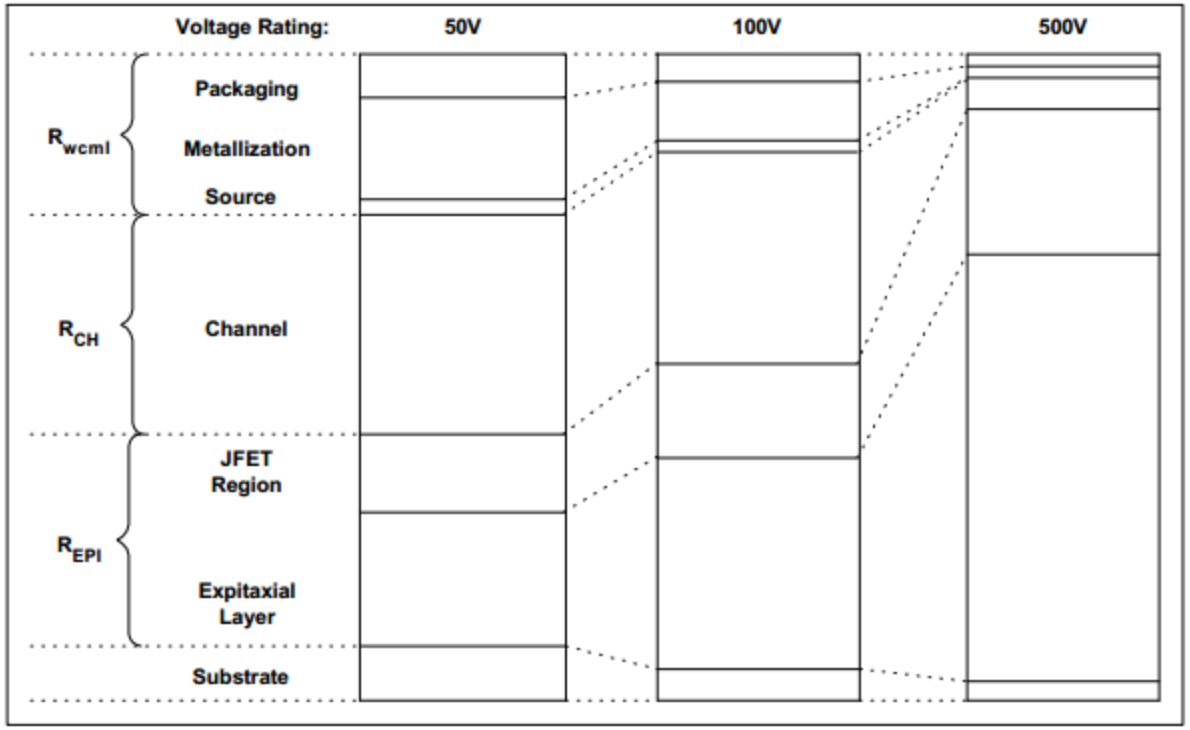
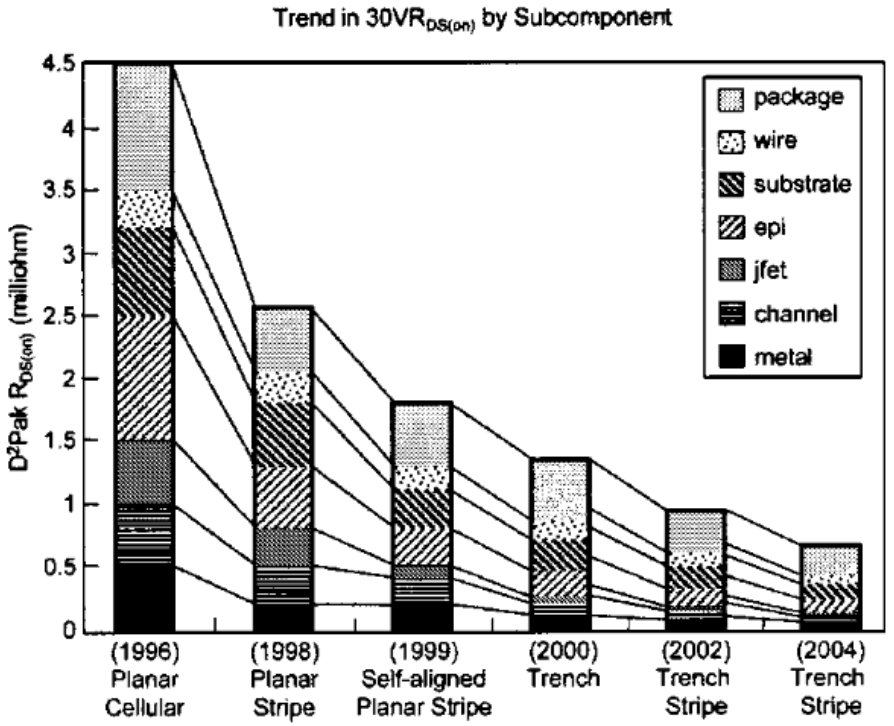


Figure 9. Relative Contributions to $R_{DS(on)}$ With Different Voltage Ratings.



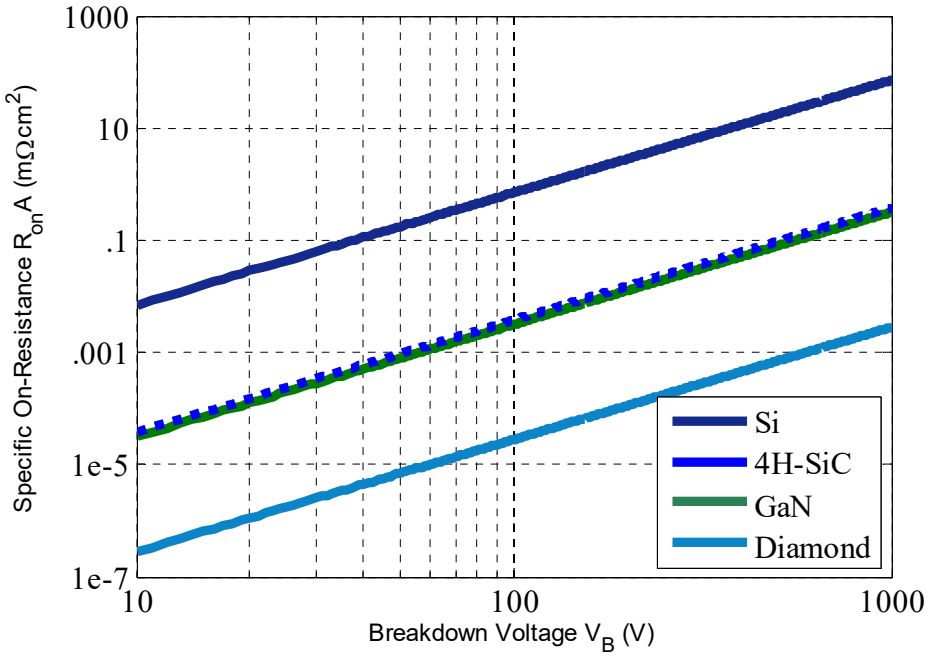
WBG Materials

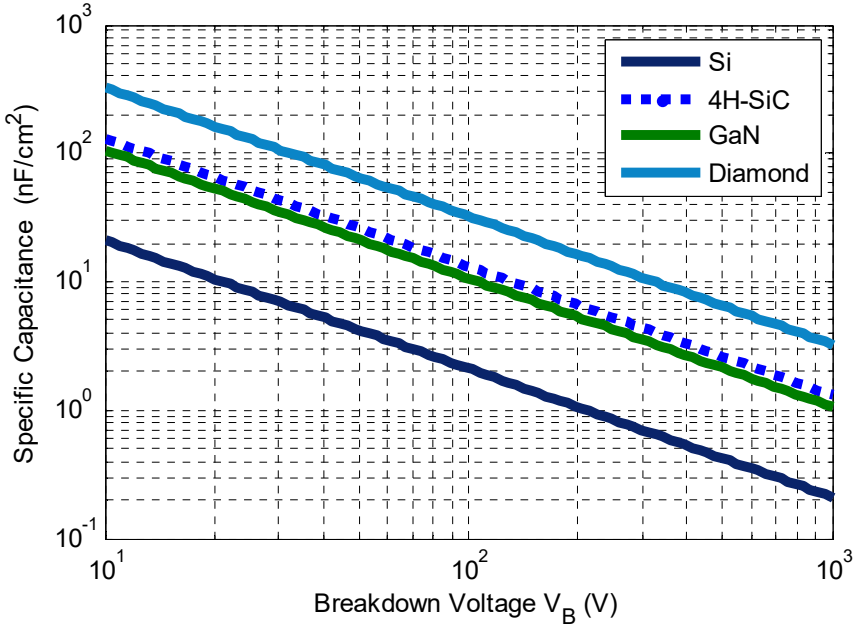
Table 2.1. Physical characteristics of Si and the major WBG semiconductors

Property	Si	GaAs	6H-SiC	4H-SiC	GaN	Diamond
Bandgap, E_g (eV)	1.12	1.43	3.03	3.26	3.45	5.45
Dielectric constant, ε_r[a]	11.9	13.1	9.66	10.1	9	5.5
Electric breakdown field, E_c (kV/cm)	300	400	2,500	2,200	2,000	10,000
Electron mobility, μ_n ($cm^2/V{\cdot}s$)	1,500	8,500	500 80	1,000	1,250	2,200
Hole mobility, μ_p ($cm^2/V{\cdot}s$)	600	400	101	115	850	850
Thermal conductivity, λ (W/cm·K)	1.5	0.46	4.9	4.9	1.3	22
Saturated electron drift velocity, v_{sat} ($\times 10^7$ cm/s)	1	1	2	2	2.2	2.7

[a] $\varepsilon = \varepsilon_r \cdot \varepsilon_o$ where $\varepsilon_o = 8.85 \times 10^{-14}$ F/cm.

B Ozpineci, L M Tolbert, "Comparison of Wide-Bandgap Semiconductors for Power Electronics Applications"



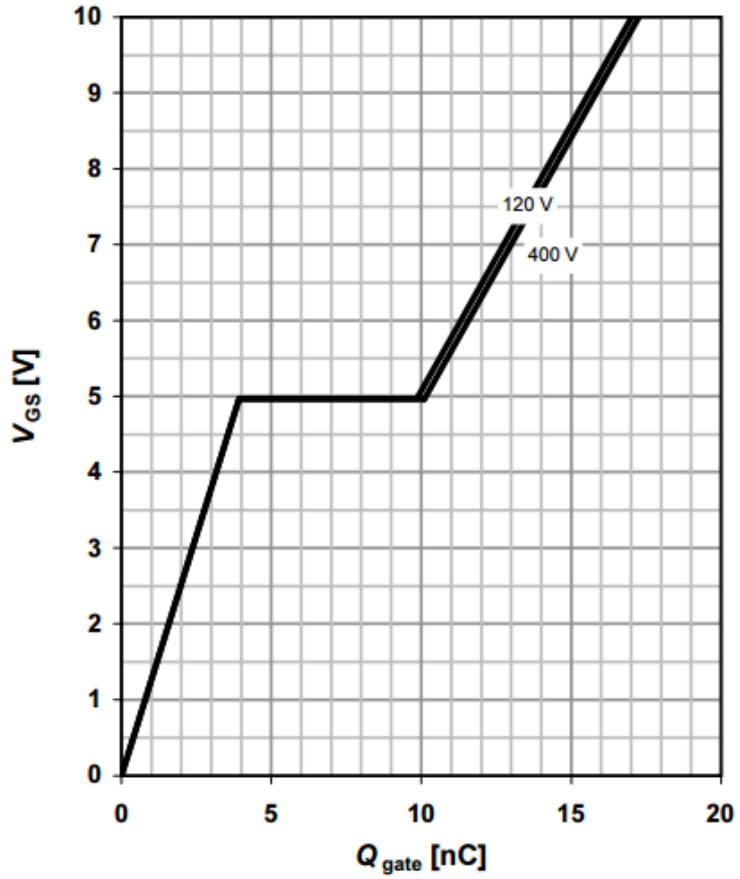


Gate Charge

9 Typ. gate charge

V_{GS}=f(Q_{gate}); I_D=5.2 A pulsed

parameter: V_{DD}



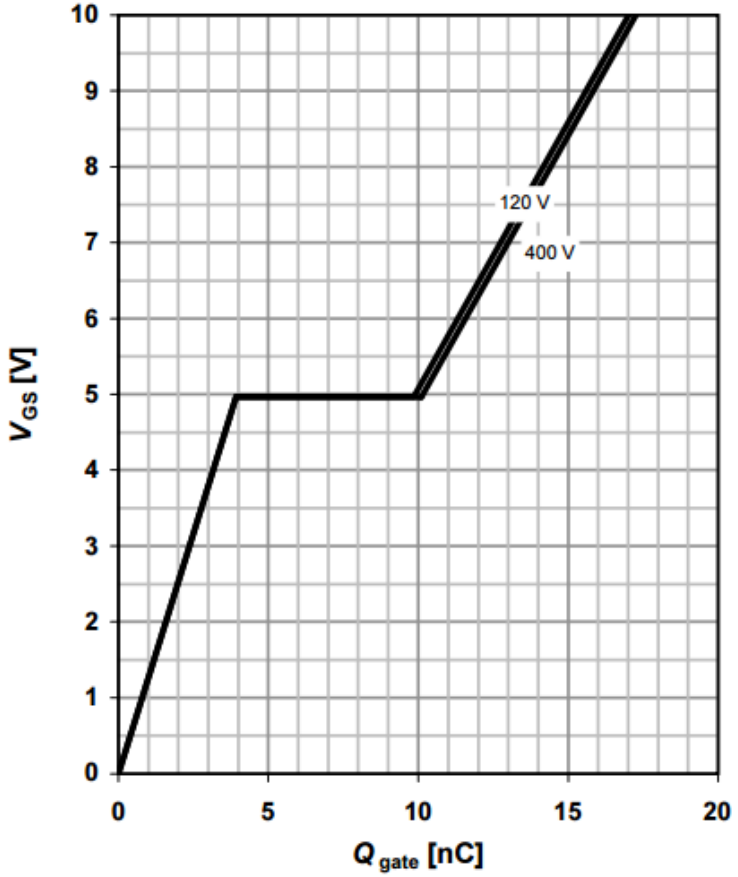
Overlap Time

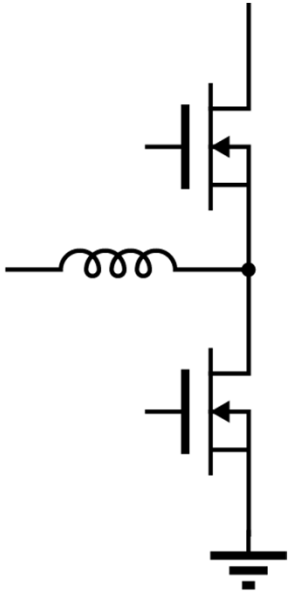
9 Typ. gate charge

V_{GS}=f(Q_{gate}); I_D=5.2 A pulsed

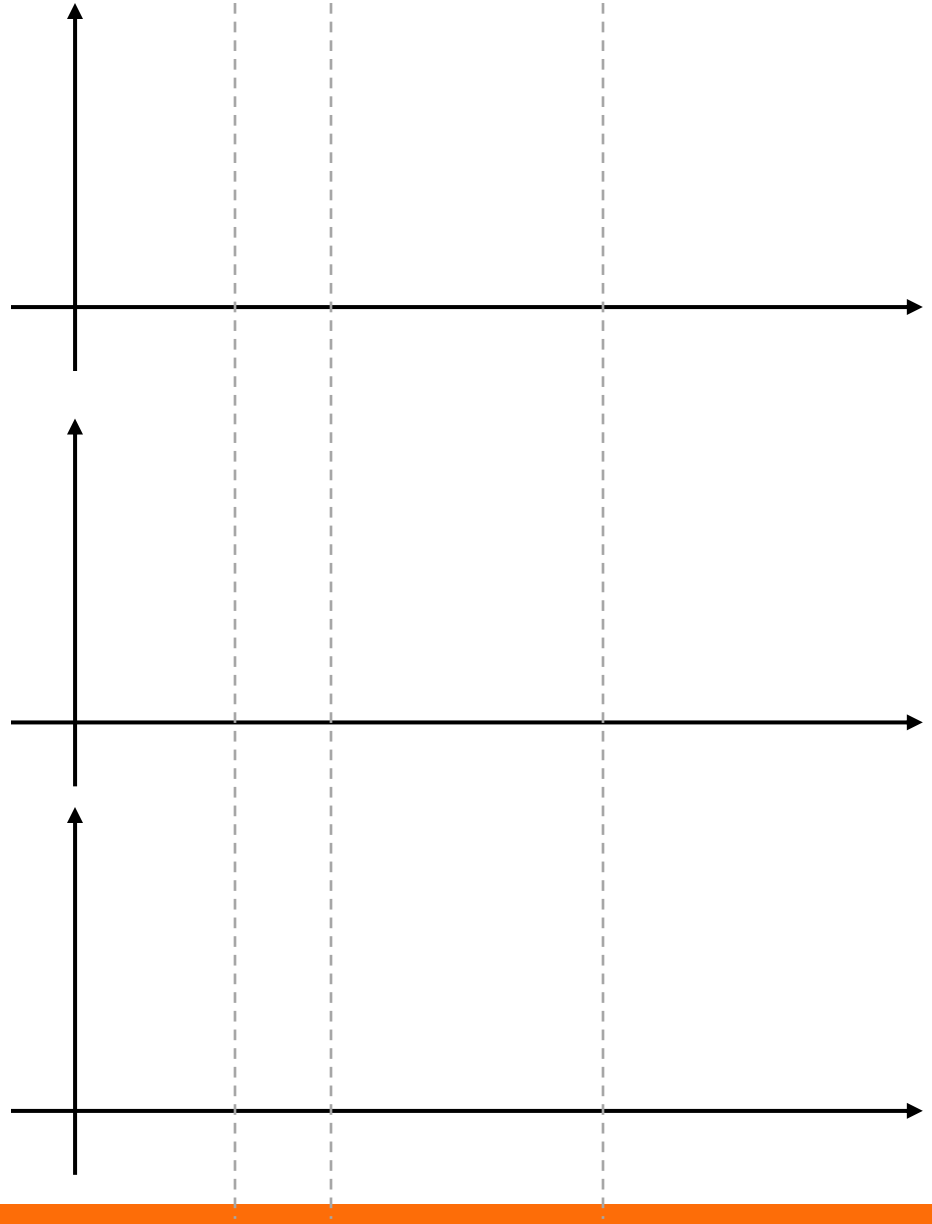
parameter: V_{DD}

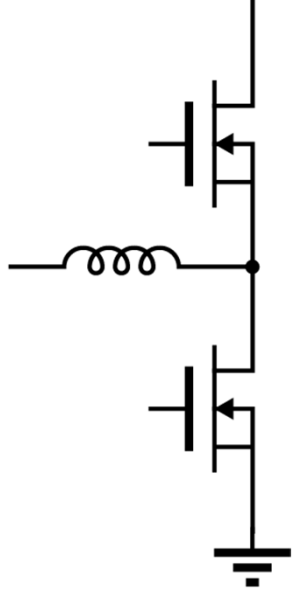
Gate threshold voltage	$V_{GS(th)}$	V_{DS}=V_{GS}, I_D=0.34 mA	2.5	3	3.5	
Gate resistance	R_G	f=1 MHz, open drain	-	1.8	-	Ω

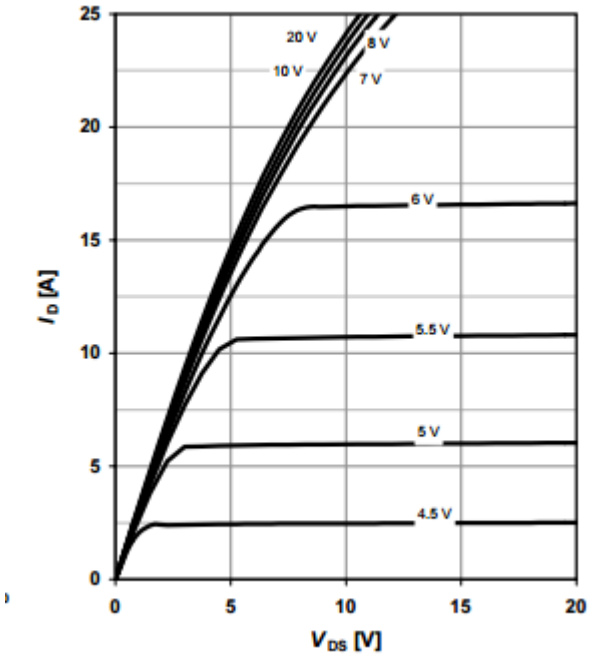




FET Turn-On







Device Transconductance